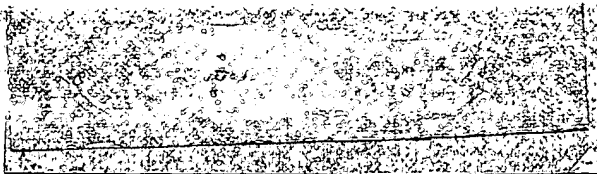


Class	Subclass
ISSUE CLASSIFICATION	



PAYMENT NUMBER

U.S. UTILITY Patent Application

1997-07-20 21

APPLICATION NO. 09/911741	CONT/PRIOR F	CLASS 438-156	SUBCLASS 107	ART UNIT 2812	EXAMINER Kackar
APPLICANTS Kouji Tometsuka					
TITLE Substrate processing apparatus					
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